

Notice of References Cited

Application/Control No.

10/595,191

Applicant(s)/Patent Under
Reexamination
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Examiner

NICHOLAS LEE

Art Unit

2627

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0114474 a1	06-2004	Park et al.	369/030.05
*	B	US-2005/0025007 a1	02-2005	Park, Yong Cheol	369/047.22
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	D	US-			
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	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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